

More General Geometries

- Euler-Bernoulli beam theory works well for simple geometries
- But how can we handle more complicated ones?
- Example: tapered cantilever beam
- Objective: Find an expression for displacement as a function of location x under a point load F applied at the tip of the free end of a cantilever with tapered width $W(x)$

Top view of cantilever's $W(x)$

$W(x) = W(1 - \frac{x}{2L_c})$

50% taper

$x = L_c$

F

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Solution: Use Principle of Virtual Work

- In an energy-conserving system (i.e., elastic materials), the energy stored in a body due to the quasi-static (i.e., slow) action of surface and body forces is equal to the work done by these forces ...
- Implication: if we can formulate **stored energy** as a function of the deformation of a mechanical object, then we can determine how an object responds to a force by determining the shape the object must take in order to **minimize** the **difference U** between the stored energy and the work done by the forces:

$$U = \text{Stored Energy} - \text{Work Done}$$

- Key idea: we don't have to reach $U = 0$ to produce a very useful, approximate *analytical* result for load-deflection

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More Visual Description ...

Same problem as before: Take a beam & apply a force:

- Apply force.
- Beam responds by bending.
- This force has done work: $W = F \cdot y_f(L_c)$
- Strain generated \rightarrow This means the beam has received an influx of stored energy

⑤ Then:
 $U = \text{Stored Energy} - \text{Work Done} \rightarrow 0$
When we choose the right shape! (This is how we get the beam's response to F !)

magnitude determined by its deformed shape

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Fundamentals: Energy Density

- Strain energy density: $[J/m^3]$** $W(\Omega) = \int_0^Q \frac{Q}{C} dQ \rightarrow$ charging a capacitor from 0 \rightarrow Q takes this much work stored energy on a capacitor
- To find work done in straining material

This is a definition, so really can just say it's a definition.

$$w = \int_0^{\epsilon_x} \sigma_x d\epsilon_x \quad \text{x-axis normal stress term}$$

$\sigma_x(\epsilon_x) \rightarrow$ relates stress to strain @ position (x, y, z)

$$[\sigma_x = E\epsilon_x] \Rightarrow w = \int_0^{\epsilon_x} E\epsilon_x d\epsilon_x = \frac{1}{2} E\epsilon_x^2$$

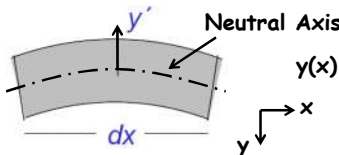
$W(q_1) = \int_0^{q_1} e(q) dq$ $q = \text{displacement}$ $e = \text{effort}$ } Generic Definition of Work

- Total strain energy $[J]$:**
- Integrate over all strains (normal and shear)

$$W = \iiint \left(\frac{1}{2} E(\epsilon_x^2 + \epsilon_y^2 + \epsilon_z^2) + \frac{1}{2} G(\gamma_{xy}^2 + \gamma_{xz}^2 + \gamma_{yz}^2) \right) dV$$

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Bending Energy Density



$y(x)$ = transverse displacement of neutral axis

- First, find the bending energy dW_{bend} in an infinitesimal length dx : *W = width*

$$dW_{\text{bend}} = W dx \int_{-h/2}^{h/2} \frac{1}{2} E \epsilon_x^2(y') dy'$$

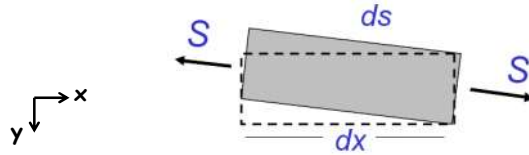
$$\left[\frac{1}{R} = \frac{d^2 y}{dx^2}, \epsilon_x = \frac{y'}{R} \right] \Rightarrow \epsilon_x(y') = y' \frac{d^2 y}{dx^2}$$

$$dW_{\text{bend}} = W dx \int_{-h/2}^{h/2} \frac{1}{2} E \left[y' \frac{d^2 y}{dx^2} \right]^2 dy' = \frac{1}{2} E \left(\frac{W h^3}{12} \right) \left(\frac{d^2 y}{dx^2} \right)^2 dx$$

$$\therefore W_{\text{bend}} = \frac{1}{2} E I_z \int_0^L \left(\frac{d^2 y}{dx^2} \right)^2 dx$$

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Energy Due to Axial Load



- Strain due to axial load S contributes an energy dW_{stretch} in length dx , since lengthening of the different element dx (to ds) results in a strain ϵ_x

Binomial Theorem

$$ds = [(dx)^2 + (dy)^2]^{1/2} = dx \left[1 + \left(\frac{dy}{dx} \right)^2 \right]^{1/2} \approx dx \left[1 + \frac{1}{2} \left(\frac{dy}{dx} \right)^2 \right]$$

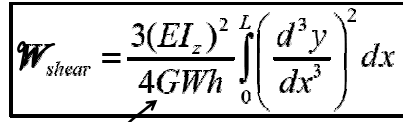
$$\therefore \epsilon_x = \frac{ds - dx}{dx} = \frac{1}{2} \left(\frac{dy}{dx} \right)^2$$

Axial Strain Energy

$$[dW_{\text{axial}} = S \epsilon_x dx = \frac{1}{2} S \left(\frac{dy}{dx} \right)^2 dx] \Rightarrow W_{\text{axial}} = \frac{1}{2} S \int_0^L \left(\frac{dy}{dx} \right)^2 dx$$

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Shear Strain Energy



$$W_{\text{shear}} = \frac{3(EI_z)^2}{4GWh} \int_0^L \left(\frac{d^3 y}{dx^3} \right)^2 dx$$

Shear Modulus

- See W.C. Albert, "Vibrating Quartz Crystal Beam Accelerometer," Proc. ISA Int. Instrumentation Symp., May 1982, pp. 33-44

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Applying the Principle of Virtual Work

- Basic Procedure:**
 - Guess the form of the beam deflection under the applied loads \rightarrow guess $y(x, F)$
 - Vary the parameters in the beam deflection function in order to minimize:

Sum strain energies Assumes point load

$$U = \sum_j W_j - \sum_i F_i u_i$$

Displacement at point load

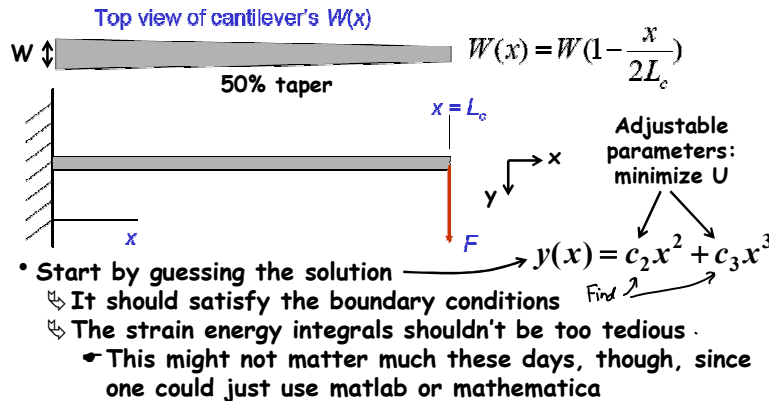
- Find minima by simply setting derivatives to zero
- See Senturia, pg. 244, for a general expression with distributed surface loads and body forces

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Lec16m1: Energy Methods

Example: Tapered Cantilever Beam

- **Objective:** Find an expression for displacement as a function of location x under a point load F applied at the tip of the free end of a cantilever with tapered width $W(x)$



- Start by guessing the solution
 - ↳ It should satisfy the boundary conditions
 - ↳ The strain energy integrals shouldn't be too tedious.
 - This might not matter much these days, though, since one could just use matlab or mathematica

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Strain Energy And Work By F

$$U = \mathcal{W}_{bend} - F \cdot y(L_c)$$

$$\mathcal{W}_{bend} = \frac{1}{2} E \int_0^{L_c} I_z(x) \left(\frac{d^2 y}{dx^2} \right)^2 dx \quad (\text{Bending Energy})$$

$$I_z(x) = \frac{W(x)h^3}{12}$$

$$\frac{d^2 y}{dx^2} = 2c_2 + 6c_3 x$$

(Using our guess)

$$W(x) = W(1 - \frac{x}{2L_c})$$

Tip Deflection

$$= \frac{1}{24} E W h^3 \int_0^{L_c} (1 - \frac{x}{2L_c}) (2c_2 + 6c_3 x)^2 dx - F(c_2 L_c^2 + c_3 L_c^3)$$

$\underbrace{\hspace{10em}}_{\text{work}}$

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Find c_2 and c_3 That Minimize U

- Minimize $U \rightarrow$ basically, find the c_2 and c_3 that brings U closest to zero (which is what it would be if we had guessed correctly)
- The c_2 and c_3 that minimize U are the ones for which the partial derivatives of U with respect to them are zero:

$$\frac{\partial U}{\partial c_2} = 0 \quad \frac{\partial U}{\partial c_3} = 0$$

- Proceed:

↳ First, evaluate the integral to get an expression for U :

$$U = E W h^3 \left\{ \frac{5c_3^2}{16} L_c^3 + \frac{c_2 c_3}{3} L_c^2 + \frac{c_2^2}{8} L_c \right\} - F(c_2 L_c^2 + c_3 L_c^3)$$

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Minimize U (cont)

- Evaluate the derivatives and set to zero:

$$\frac{\partial U}{\partial c_2} = 0 = \left(\frac{E W h^3}{3} c_3 - F \right) L_c^2 + \left(\frac{E W h^3}{4} c_2 \right) L_c$$

$$\frac{\partial U}{\partial c_3} = 0 = \left(\frac{5}{8} E W h^3 c_3 - F \right) L_c^3 + \left(\frac{E W h^3}{3} c_2 \right) L_c^2$$

- Solve the simultaneous equations to get c_2 and c_3 :

$$c_2 = \left(\frac{84}{13} \right) \frac{F L_c}{E W h^3} \quad c_3 = - \left(\frac{24}{13} \right) \frac{F}{E W h^3}$$

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The Virtual Work-Derived Solution

- And the solution:

$$y(x) = \left(\frac{24F}{13EWh^3} \right) \left(\left(\frac{7}{2} \right) L_c - x \right) x^2$$
- Solve for tip deflection and obtain the spring constant:

$$y(L_c) = \left(\frac{24F}{13EWh^3} \right) \left(\frac{5}{2} \right) L_c^3 \quad k_c = F / y(L_c) = \left(\frac{13EWh^3}{60L_c^3} \right)$$
- Compare with previous solution for constant-width cantilever beam (using Euler theory):

$$y(L_c) = \left(\frac{4F}{EWh^3} \right) L_c^3 \longrightarrow \text{13\% smaller than tapered-width case}$$

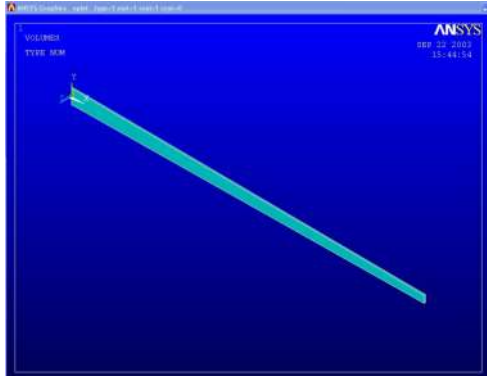
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Comparison With Finite Element Simulation

- Below: ANSYS finite element model with

$$L = 500 \mu\text{m} \quad W_{\text{base}} = 20 \mu\text{m} \quad E = 170 \text{ GPa}$$

$$h = 2 \mu\text{m} \quad W_{\text{tip}} = 10 \mu\text{m}$$



- Result: (from static analysis)

$$k = 0.471 \mu\text{N/m}$$
- This matches the result from energy minimization to 3 significant figures

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Need a Better Approximation?

- Add more terms to the polynomial
- Add other strain energy terms:
 - Shear: more significant as the beam gets shorter
 - Axial: more significant as deflections become larger
- Both of the above remedies make the math more complex, so encourage the use of math software, such as Mathematica, Matlab, or Maple
- Finite element analysis is really just energy minimization
- If this is the case, then why ever use energy minimization analytically (i.e., by hand)?
 - Analytical expressions, even approximate ones, give insight into parameter dependencies that FEA cannot
 - Can compare the importance of different terms
 - Should use in tandem with FEA for design

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